

IBM DOCKET: FIS920030423US1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR: Christopher P. Ausschnitt) EXAMINER:

SERIAL NO.:) ART UNIT:

FILING DATE:) DATE: January 23, 2004

FOR: Method of Patterning
Process Metrology Based
on the Intrinsic Focus
Offset

INFORMATION DISCLOSURE STATEMENT

Mail Stop _____
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 CFR 1.56, 1.97 and 1.98, the following items are made of record to assist the Patent & Trademark Office in its examination of this application and is, in the opinion of the attorney designated below for applicant(s), information relevant to the closest prior art of which that person is aware. The filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made or that no other art than that identified exists.

PATENT APPLICATION
SERIAL NO.

INVENTOR

FILING DATE

09/765,148

Ausschnitt

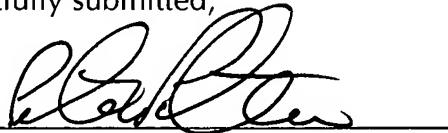
January 17, 2001

<u>FOREIGN PAT. NO.</u>	<u>COUNTRY</u>	<u>PUBLICATION DATE</u>
WO 03/001297 A2	PCT	January 3, 2003

A copy of each of the foregoing items and Form PTO 1449 are enclosed herewith.

Respectfully submitted,

By:



Attorney: **Peter W. Peterson**

Reg. No.: **31,867**

DeLIO & PETERSON, LLC
121 Whitney Avenue
New Haven, CT 06510
(203) 787-0595

ibmf100421000suppids1

EXPRESS MAIL NO.:

ER 046066269DS

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING
DEPOSITED WITH THE U.S. POSTAL SERVICE AS EXPRESS
MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER OF
PATENTS AND TRADEMARKS, WASHINGTON, D.C. 20231
APPLICANT AND/OR ATTORNEY REQUESTS THE DATE OF
DEPOSIT AS THE FILE DATE.

DATE OF DEPOSIT:

2/3/04

BY SIGNATURE & DATE:

Raun By Mar 2/3/04

FORM PTO-1449 (Modified)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO.: FIS920030423US1	SERIAL NO.:
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		APPLICANT: Christopher P. Ausschnitt	
(Use several sheets if necessary) (37 CFR 1.98(b))		FILING DATE:	GROUP:

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
	AA	5,953,128	09/14/1999	Ausschnitt et al.			
	AB	5,965,309	10/12/1999	Ausschnitt et al.			
	AC	5,976,740	11/02/1999	Ausschnitt et al.			
	AD	6,004,706	12/21/1999	Ausschnitt et al.			
	AE	6,027,842	02/22/2000	Ausschnitt et al.			
	AF	6,128,089	10/03/2000	Ausschnitt et al.			
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

	AQ	
	AR	
	AS	
EXAMINER		DATE CONSIDERED
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance <u>and</u> not considered. Include copy of this form with next communication to applicant.		

SUPPLEMENTAL INFORMATION DISCLOSURE

Sheet 2 of 2

FORM PTO-1449 (Modified)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO.: FIS920030423US1	SERIAL NO.:
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT		APPLICANT: Christopher P. Ausschnitt	
(Use several sheets if necessary) (37 CFR 1.98(b))		FILING DATE:	GROUP:

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
	AT						
	AU						
	AV						
	AW						
	AX						
	AY						
	AZ						

		U.S. PATENT APPLICATION NO.	PUBLICATION DATE	INVENTOR			
	BA	S/N 09/765,148	01/17/2001	Ausschnitt			
	BB						
	BC						
	BD						

FOREIGN PATENT DOCUMENTS

			PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB- CLASS	TRANSLATION YES	NO
	BE	WO 03/001297 A2	01/03/2003	PCT				
	BF							
	BG							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

	BH	
	BI	
	BJ	
EXAMINER		DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.